AMENDMENTS TO THE CLAIMS

This listing of claims will replace all prior versions, and listings, of claims in the application.

1. (Original) An apparatus comprising:

a metal deposition tool having annealing capability.

2. (Original) The apparatus of claim 1 further comprising an annealing chamber on said metal

deposition tool.

3. (Original) The apparatus of claim 2 wherein said metal deposition tool is an electroplating

tool.

4. (Original) The apparatus of claim 2 wherein said metal deposition tool is a chemical vapor

deposition (CVD) tool.

5. (Original) The apparatus of claim 1 wherein said metal deposition tool has a plurality of

metal deposition chambers, said metal deposition tool being modified to replace one of said

metal deposition chambers with an annealing chamber.

6. (Original) The apparatus of claim 5 wherein said metal deposition tool is an electroplating

tool and said metal deposition chamber is an electroplating chamber.

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7. (Original) The apparatus of claim 5 wherein said metal deposition tool is a chemical vapor

deposition (CVD) tool and said metal deposition chamber is a chemical vapor deposition

(CVD) chamber.

8. (Original) The apparatus of claim 1 wherein said metal deposition tool includes at least one

metal deposition chamber and an annealing chamber on said metal deposition tool.

9. (Original) The apparatus of claim 8 wherein said metal deposition tool is an electroplating

tool and said metal deposition chamber is an electroplating chamber.

10. (Original) The apparatus of claim 8 wherein said metal deposition tool is a chemical vapor

deposition (CVD) tool and said metal deposition chamber is a chemical vapor deposition

(CVD) chamber.

11. (Original) The apparatus of claim 8 wherein said annealing chamber includes heat lamps.

12. (Original) The apparatus of claim 8 wherein said annealing chamber is a furnace.

13. (Original) The apparatus of claim 8 further comprising a robot, wherein said robot moves a

wafer from said metal deposition chamber to said annealing chamber.

14. (Original) An apparatus comprising:

an chemical mechanical polishing (CMP) tool having annealing capability.

Attorney Docket No.: 42390P6934D Express Mail Label No.: EL 981993224 US 15. (Original) The apparatus of claim 14 further comprising an annealing chamber on said CMP

tool.

16. (Original) The apparatus of claim 14 wherein said CMP tool has a plurality of CMP

platforms, said CMP tool being modified to replace one of said CMP platforms with an

annealing chamber.

17. (Original) The apparatus of claim 14 wherein said CMP tool includes at least one CMP

platform and an annealing chamber on said CMP tool.

18. (Original) The apparatus of claim 14 wherein said annealing chamber includes heat lamps.

19. (Original) The apparatus of claim 14 wherein said annealing chamber is a furnace.

20. (Original) The apparatus of claim 14 further comprising a robot, wherein said robot moves a

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wafer from said annealing chamber to said CMP platform.

21. – 30. (Cancelled)

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